Application/Control Number: 10/500,278

Art Unit: 3723

1. An examiner's amendment to the record appears below. Should the changes and/or additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR 1.312. To ensure consideration of such an amendment, it MUST be submitted no later than the payment of the issue fee.

Authorization for this examiner's amendment was given in a telephone interview with Mr. Bousquet on 12 December 2007.

The application has been amended as follows:

Claim 27, line 10, after "plurality of" insert –devices for fixing the upper turn table to a support, the fixing devices forming--; line 13, after "plurality of" insert—bearing devices forming--.

Claim 32, line 8, after "plurality of" insert –devices for fixing the upper turn table to a support, the fixing devices forming—; line 11, after "plurality of" insert—bearing devices forming—.

Amend claim 64 to read :

64. (Amended) The wafer double-side polishing method according to claim 27, wherein: the load supporting points of the upper turn table are fixing devices; and the load supporting points of the lower turntable the bearing devices are thrust bearings.

65. (New) The wafer double-side polishing method according to claim 32, wherein: the load supporting points of the upper turn table are fixing devices; and the load supporting points of the lower turntable the bearing devices are thrust bearings.

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